

Docket No.: 20241/0203479-US0  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Nobuo KIMURA *et al.*

Application No.: 10/553,109

Confirmation No.: 2398

Filed: March 13, 2006

Art Unit: 1792

For: METHOD FOR PRODUCING ORGANIC THIN  
FILM

Examiner: William P. Fletcher III

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

**INTRODUCTORY COMMENTS**

In response to the Final Office Action dated April 2, 2009, finally rejecting claims 1-4, 12, 19, 25-29, 55, and 57-62, please amend the above-identified U.S. patent application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.

It is believed that no additional fees are required for this Response. However, should additional fees be necessary in connection with the filing of this Response, or if a petition for extension of time is required for timely acceptance of the same, the Commissioner is hereby

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authorized and requested to charge Deposit Account No. 04-0100 for any such fees, and Applicant hereby petitions for any needed extension of time.